

UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandra, Verginia 22313-1450

RIR DATA SHEET

CONFIRMATION NO. 7805

SERIAL NUMBER 10/085,046	FILING or 371(c) DATE 03/01/2002	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 03500,010530.5
	RULE			00000.010000.0

APPLICANTS

Kivofumi Sakaguchi, Isehara-shi, JAPAN: Takao Yonehara, Atsugi-shi, JAPAN; Nobuhiko Sato, Yokohama-shi, JAPAN:

" CONTINUING DATA " This application is a CIP of 09/161.775 09/29/1998 ABN

which is a DIV of 08/863 717 05/27/1997 PAT 5 856 229

which is a CON of 08/401,237 03/09/1995 ABN

This application 10/085.046 03/01/2002

is a CIP of 09/734 667 12/13/2000 ABN

which is a DIV of 09/212.432 12/16/1998 PAT 6.246.068 which is a DIV of 08/729,722 10/07/1996 PAT 5.854.123

This application 10/085,046 03/01/2002

is a CIP of 09/933.711 08/22/2001 ABN

which is a DIV of 09/840 895 04/25/2001 PAT 6 350 702 which is a DIV of 08/807.604 02/27/1997 PAT 6.294.478

JAPAN 39389 03/10/1994

JAPAN 45441 03/06/1995 JAPAN 260100 10/06/1995

JAPAN 41709 02/28/1996

JAPAN 264386 10/04/1996

** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** My. Du.

	04/2	3/200
Foreign	Pnority	claimed

35 USC 119(a-d) o	onditions met V Yes No	Met after Allowance	COUNTRY	DRAWINGS		CLAIMS
Verified and	/GEORGE R FOURSON III/		JAPAN	24	60	16
Acknowledged	Examiner's Signature	Intuit				

ADDRESS

FITZPATRICK CELI A HARPER & SCINTO 1290 Avenue of the Americas NEW YORK, NY 10104-3800

UNITED STATES

TITLE

Process for production of semiconductor substrate

1		☐ All Fees
EII ING EEE	FEES: Authority has been given in Paper	1.16 Fees (Filing)
RECEIVED	Noto charge/credit DEPOSIT ACCOUNT	1.17 Fees (Processing Ext. of time)